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|--|--|---------------------------------|-------------|-----|------------------------|------------|-------------------------------------|-------------|
| APPLICANTS | | | | | | | | |
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| ** CONTINUING DATA ********************************** | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/10/2003 | | | | | | | | |
| Foreign Priority claimed yes no 35 USC 119 (a-d) conditions yes no Me | | STA ⁻ | TE OR | SHE | EETS | тот | AL | INDEPENDENT |
| met Verified and | Allowance | D cou | NTRY NCE | | WING 9 | CLAI 44 | | CLAIMS 5 |
| ADDRESS 28765 WINSTON & STRAWN LLP 1700 K STREET, N.W. WASHINGTON, DC 20006 | | | | | | | | |
| TITLE Process for transferring a layer of strained semiconductor material | | | | | | | | |
| | | | | | □ All | Fees | | |
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